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Jc682 U.S. PTO



09/21/00

Docket No. 2813.P1/USA/SILICON

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
 Commissioner for Patents
 Washington, D.C. 20231

Jc682 U.S. PTO

09/667362



Re: Inventor(s): Grimbergen, et al.
 Title: Reducing Deposition of Process Residues on a Surface in a Chamber

Transmitted herewith is the continuation in part of U.S. Application Serial No. 09/096,728, filed on June 11, 1998, including:

- ☒ Specification, claims and abstract, totaling 36 pages.
- ☒ Drawings totaling 9 pages, Formal X Informal.
- ☒ Declaration and Power of Attorney.
- ☒ Information Disclosure Statement and PTO-1449 form
- ☒ Assignment of the invention to Applied Materials, Inc. and Assignment Recordation Cover Sheet
- ☒ Post Card for return

FEE CALCULATION					
Fee Items	Claims Filed	Included with Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	69	- 20 =	49	x 18.00	882.00
Independent Claims	8	- 3 =	5	x 78.00	390.00
Basic Filing Fee				690.00	690.00
TOTAL FEES					\$1962.00

- ☒ The Commissioner is hereby authorized to charge \$1962.00 to Deposit Account No. 50-1074. A duplicate copy of this transmittal is enclosed.
- ☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. 50-1074.
- ☒ Please address all future correspondence to:

APPLIED MATERIALS, INC.
Patent Department
P.O. Box 450A
Santa Clara, CA 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to:

Box Patent Application
 Commissioner for Patents
 Washington, D.C. 20231

Express Mail Receipt No. EL356915396US

Date of Deposit

9/21/2000By BETH MULCAHY

Signature

Robert W. Mulcahy

Respectfully submitted,

Robert W. Mulcahy
 Registration No. 25,436